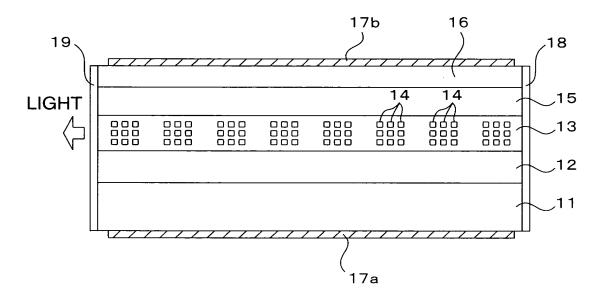
Title: METHOD OF MANUFACTURING A SEMICONDUCTOR LASER
By: Nobuaki HATORI
Docket No.: 030941

FIG. 1 (PRIOR ART)



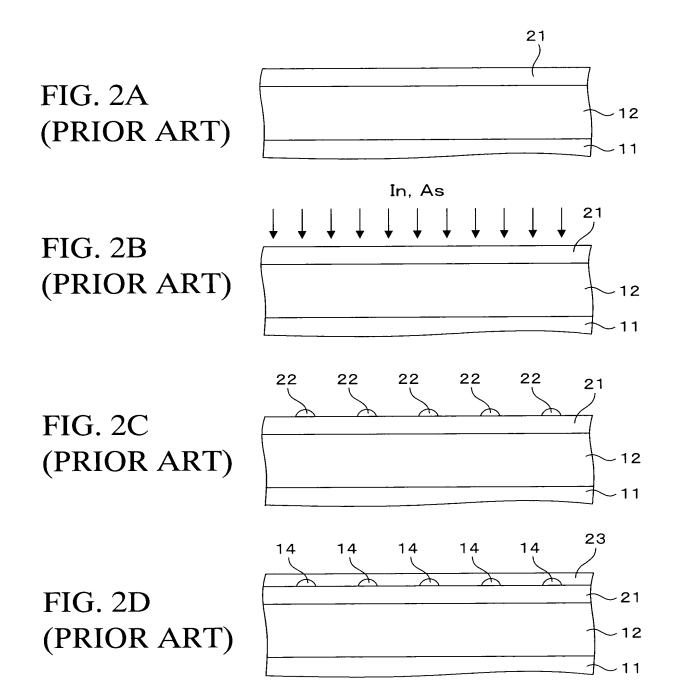


FIG. 2E (PRIOR ART)

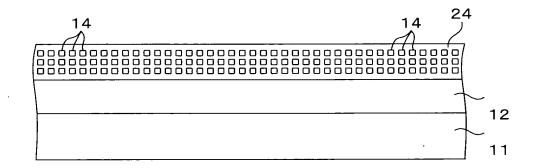


FIG. 2F (PRIOR ART)

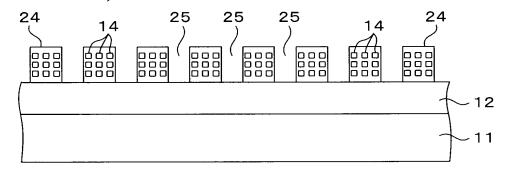
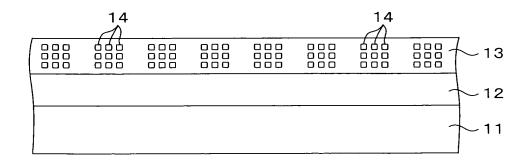
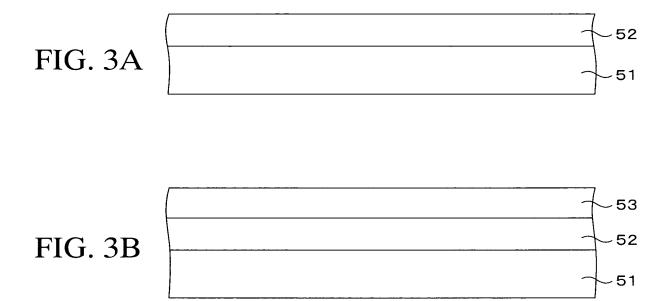
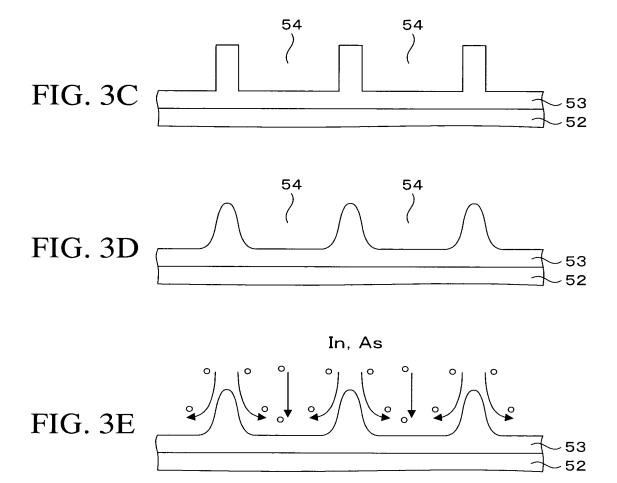
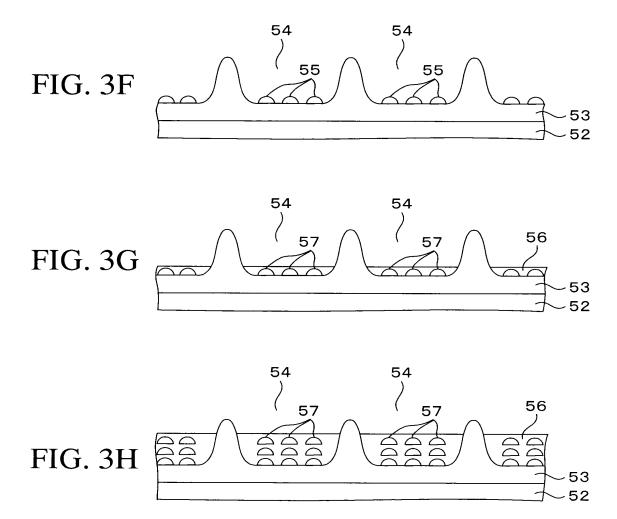


FIG. 2G (PRIOR ART)









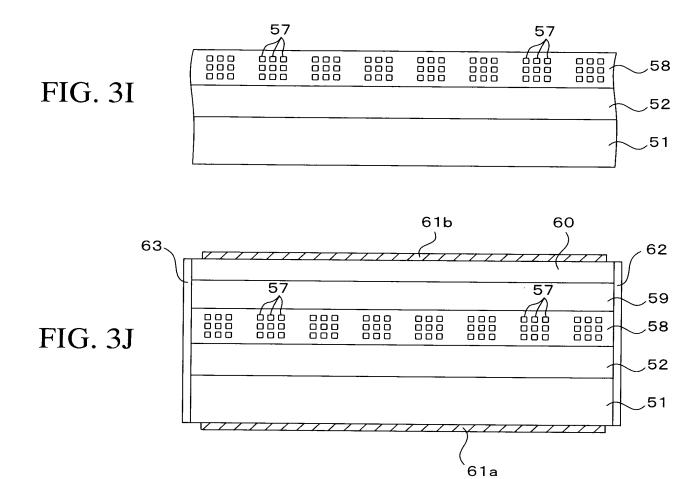


FIG. 4

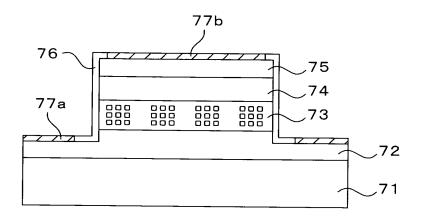


FIG. 5

